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| Filing Date: | July 10, 2003 |
| First Named Inventor: | Oh |
| Group: | 1795 |
| Examiner: | Phasge, Arun S. |
| Attorney Docket No.: | 421/170/8/2 CIP |

List of Documents Cited by Applicant

U.S. PATENT DOCUMENTS

| Examiner Initial | Cite No. | Document Number | Publication Date | Name of Patentee or Applicant of Cited Document | Pages, Columns, Lines, where relevant passages or relevant figures appear |
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FOREIGN PATENT DOCUMENTS

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OTHER DOCUMENTS

| Examiner Initials | Cite No. | Include Author (in CAPITAL LETTERS), Title, Journal, Date, Pertinent Pages, Etc. | T |
|-------------------|----------|---|---|
| | 1. | Office Action from the Korean Intellectual Property Office for Korean Patent Application No. 10-2006-7000476 dated February 19, 2008. | |
| | 2. | http://web.archive.org/web/20030507193839/http://snf.sanford.edu/Process/Lithography/liftoff.html , edited 2000.8.14. | |
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